

Dear Customer

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Ref.No. G2K-R-090630-2
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Subject:

Announcement of Ass'y and Test Line transfer for Mitsubishi Si RF Discrete Transistor.

This document shows Ass'y and Test Line transfer for Mitsubishi Si RF discrete Transistor. Miyoshi Electronics Corporation decides to transfer equipments as follows. The purpose of this line transfer is aggregate of production line. This transfer will improve the manufacturing technology and the productivity such as know-how of the manufacturing equipment usage in the future.

1. Device type and time of transfer

Device type	Current location	After transfer	Schedule
PMM PKG discrete*	Shimane Masuda Electronics	MEC Semicon	Equipment Transfer Sep. 2009 Production start Oct. 2009

*RD05MMP1, RD09MUP2, RD12MVP1

2. Process change

Production flowchart, equipments, process and specification(process & quality) are not changed.
Only location of equipments and operator is changed.

3. Schedule

	Jun	Jul	Aug	Sep	Oct	Nov	Dec
Preparation/Training			→				
Transfer/Set up				→			
Mass-Production					→		

Best Regards